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## BIB DATA SHEET

CONFIRMATION NO. 8539

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.	
10/562,235	10/31/2006 RULE	438	2813	P35795	
<b>APPLICANTS</b> Syouji Nogami, Tokyo, JAPAN; Yukichi Horioka, Tokyo, JAPAN; Shoichi Yamauchi, Tokyo, JAPAN; <b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP05/06268 03/31/2005 <b>** FOREIGN APPLICATIONS *****</b> JAPAN 2004-110634 04/05/2004 <b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 02/27/2007					
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and /SONYA D MCCALL SHEPARD/ Acknowledged <u>Examiner's signature</u> <u>Initials</u>		<input type="checkbox"/> Met after Allowance <b>STATE OR          COUNTRY</b> JAPAN	<b>SHEETS          DRAWINGS</b> 4	<b>TOTAL          CLAIMS</b> 24	<b>INDEPENDENT          CLAIMS</b> 1
<b>ADDRESS</b> GREENBLUM & BERNSTEIN, P.L.C. 1950 Roland Clarke Place Reston, VA 20191 UNITED STATES					
<b>TITLE</b> Manufacturing Method Of Semiconductor Wafer Having a Trench Structure and Epitaxial Layer					
<b>FILING FEE          RECEIVED</b> 1230	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit _____	